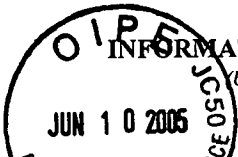


<div style="text-align: center;">  <p>INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p> </div>	Docket Number (Optional) 15689.49.4	Application Number 10/673,940
	Applicant(s) Takehiro Nakamura, et al.	
	Filing Date 9/29/2003	Group Art Unit 2631

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/K.K.1/		5,497,395	3/5/1996	Jou	375	205	4/4/1994

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FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
/K.K.2/		EP 0748074 A2	12/11/1996	Europe	H04J13	02	✓	
/K.K.3/		EP 0696113 A2	2/7/1996	Europe	H04B7	06	✓	

OTHER DOCUMENTS			(Including Author, Title, Date, Pertinent Pages, Etc.)
/K.K./	4		Canadian Intellectual Property Office Application No.: 2,485,891 2005

EXAMINER <div style="text-align: center;">/Kevin Kim/</div>	DATE CONSIDERED <div style="text-align: center;">9/26/05</div>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.